



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Uzoh et al. Serial No.: 10/698,878 Filed: October 31, 2003 Title: Methods For Depositing High Yield And Low Defect Density Conductive Films In Damascene Structures	Group Art Unit: 2829 Examiner: Not yet assigned Docket: NT-308-US
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INFORMATION DISCLOSURE STATEMENT**US PATENT DOCUMENTS**

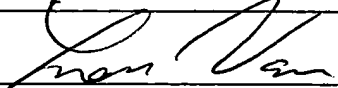
Examiner Initials	Cite No.	Document Number	Publication Date	Name of Patentee or Applicant	
LV		6,303,014	Oct., 2001	Taylor et al.	Copy Enclosed
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OTHER DOCUMENTS

Examiner Initials	Cite No.			Trans- lation

Examiner Signature		Date Considered	9/20/05
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